Form PTO-1595 (Rev. 07/05) Doc Code: OMB No. 0651-0027 (exp. 6/30/2008)	01-13-2009 TMENT OF COMMERCE				
RECORDAT					
To the Director of the U.S. Patent and Trademark Office: Ple	103543488 new address(es) below.				
1. Name of conveying party(ies)	2. Name and address of receiving party(ies)				
 Shoji SADAYAMA Yoshiharu SHIRAKAWABE Kazutaka TAKAHASHI 	Name: SII NanoTechnology Inc.				
Additional name(s) of conveying party(ies) attached? Yes Yes. 3. Nature of conveyance/Execution Date(s): Execution Date(s) NOVEMBER 27, 2008	Street Address: 8, NAKASE 1-CHOME, MIHAMA-KU				
✓ Assignment Merger □ Security Agreement Change of Name	City: CHIBA-SHI, CHIBA				
Joint Research Agreement Government Interest Assignment	State:				
Executive Order 9424, Confirmatory License	Country: JAPAN Zip: 261-8507				
Other	Additional name(s) & address(es) attached? Yes Vo				
A. Patent Application No.(s) 10/822,994	s document is being filed together with a new application. B. Patent No.(s) JAN 1 2 2009 attached? Yes VNo				
5. Name and address to whom correspondence concerning document should be mailed:	6. Total number of applications and patents involved:				
Name: BRUCE L. ADAMS, ESQ.	7. Total fee (37 CFR 1.21(h) & 3.41) \$ 40.00				
Internal Address:	Authorized to be charged by credit card				
Street Address: ADAMS & WILKS	Authorized to be charged to deposit account —— any deficiency in enclosed fee Enclosed None required (government interest not affecting title)				
17 BATTERY PLACE-SUITE 1231	8. Payment Information				
City: NEW YORK State: NY Zip: 10004	a. Credit Card Last 4 Numbers Expiration Date				
Phone Number: 212-809-3700					
Fax Number: 212-809-3704	b. Deposit Account Number <u>01-0268</u>				
Email Address:	Authorized User Name <u>ADAMS & WILKS</u>				
9. Signature:	JANUARY 9, 2009 Date				
	Date				

Documents to be recorded (including cover sheet) should be faxed to (571) 273-0140, or mailed to:

Mail Stop Assignment Recordation Services, Director of the USPTO, P.O.Box 1450, 40800 4140 A. 228880600 18822994

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ASSIGNMENT

WHEREAS, we, Shoji SADAYAMA and Yoshiharu SHIRAKAWABE residing at c/o SII NanoTechnology Inc., 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan and Kazutaka TAKAHASHI residing at c/o Seiko Instruments Inc., 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan have invented new and useful improvements in METHOD FOR MANUFACTURING A SPLIT PROBE,

for which we have prepared an application for Letters Patent of the United States of America;

AND WHEREAS, SII NanoTechnology Inc., located and doing business at 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan, is desirous of acquiring an interest therein and in the Letters Patent to be obtained therefor;

NOW, THEREFORE, be it known by all whom it may concern, that for and in consideration of Ten Dollars (\$10.00) and other good and valuable consideration to us in hand paid, the receipt of which is hereby acknowledged, we have assigned, sold and transferred and by these presents do hereby assign, sell and transfer unto the said SII NanoTechnology Inc. for the territory of the United States of America, our entire right, title and interest in and to the said invention, and in and to the said application, prepared and executed by us on May 25, 2004, filed April 13, 2004, Serial No. 10/822,994 preparatory to obtaining Letters Patent thereon and in and to any and all divisions, reissues and continuations thereof, and in and to any Letters Patent that may be granted thereon; said invention, application and Letters Patent to be held and enjoyed by the said SII NanoTechnology Inc., its legal representatives and assigns, as fully and entirely as the same would have been held by us had this assignment, sale and transfer not been made.

> PATENT REEL: 022100 FRAME: 0095

AND, we hereby covenant and agree that we will at any time upon the request and at the expense of said assignee execute and deliver any and all papers and do all lawful acts that may be necessary or desirable to perfect the title to said invention and to obtain Letters Patent therefor, and we hereby authorize and request the Honorable Commissioner of Patents and Trademarks to issue the said Letters Patent to the said SII NanoTechnology Inc. in accordance with this assignment.

	Executed	this <u>27th</u>	day of	November		008 at	
			•				
Witnes	ss:						
Masa	ki Hori			Shoji S	doyan ADAYAMA		_(L.S.)
			_(Yndiha S Yoshina:	hof Be	2 AKAWABE	(L.S.)
				Hayutaha ~	1. Roberti		/= ~ \